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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/072,415
Filing Date February 5, 2002
Inventor Ji Ung Lee et al.
Assignee Micron Technology, Inc.
Group Art Unit 2891
Examiner Steven J. Fulk
Confirmation No. 5182
Customer No. 021567
Attorney's Docket No. MI30-068
Title: **Field Effect Transistor Fabrication Methods, Field Emission Device Fabrication Methods, and Field Emission Device Operational Methods**

RESPONSE TO AUGUST 8, 2006 OFFICE ACTION

To: Mail Stop Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

Responsive to the Office Action dated August 8, 2006, Applicants amend and
remark as follows:

AMENDMENTS

01/11/2007 EFLORES 00000001 230925 10072415

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